

12-31-01

A

Atty. Docket No. AMAT/5998/CMP/CMP/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application
Assistant Commissioner of Patents and Trademarks
Washington, D.C. 20231

Re: Inventor(s): Alain Duboust; Lizhong Sun; Feng Liu; Yuchun Wang; Yan Wang; Siew Neo;
Liang-Yuh Chen

Title: ELECTROLYTE COMPOSITION AND TREATMENT FOR ELECTROLYTIC CHEMICAL
MECHANICAL POLISHING

Transmitted herewith is the patent application identified above, including:

- ☒ Specification, claims and abstract, totaling 21 pages.
☒ Drawings totaling 1 pages, Formal ☒ Informal.
 Executed Declaration and Power of Attorney.
 Information Disclosure Statement w/ Form 1449 and References.
 Assignment of the invention to **Applied Materials, Inc.**
 Assignment Recordation Cover Sheet

FEE CALCULATION					
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	43	-20=	23	x \$18.00	\$414.00
Independent Claims	8	-3=	5	x \$84.00	\$420.00
Basic Filing Fee				\$740.00	\$740.00
TOTAL FEES					\$1574.00

 The Commissioner is hereby authorized to charge to Deposit Account No.

 The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. . A duplicate copy of this transmittal is enclosed.

☒ Please address all future correspondence to: **PATENT COUNSEL
APPLIED MATERIALS, INC.
Legal Affairs Department
P.O.BOX 450A
Santa Clara, CA. 95052**

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231.

Express Mail Receipt No.: EL884620753US

Date of Deposit: 12/21/01

Signature: Robb D. Edmonds

Respectfully submitted,

Robb D. Edmonds
Robb D. Edmonds
Registration No. 46,681
(713) 623-4844

12/21/01
31025 U.S. PTO

31000 U.S. PTO
10/032275
12/21/01

12/21/01
31025 U.S. PTO